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PATENT APPLICATION TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROSHI IZAWA ET AL.

Application No.: 09/837,459

Filed: April 19, 2001

For: DEPOSITED-FILM FORMATION
APPARATUS, DEPOSITED-FILM
FORMATION PROCESS, VACUUM
SYSTEM, LEAK JUDGMENT
METHOD, AND COMPUTER-
READABLE RECORDING MEDIUM
WITH RECORDED LEAK-
JUDGMENT-EXECUTABLE
PROGRAM

Examiner: Not Yet Assigned

Group Art Unit: 2857

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JUN 05 2003
TC 1700

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JAN 17 2003

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August 12, 2002

OCT 28 2003

TC 1700

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AUG 28 2002

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Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The Examiner's attention is also directed to the following U.S. applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
08/704,138	08/28/96	1763
09/469,797	12/22/99	1763
09/478,885	01/07/00	1763
09/867,493	05/31/01	1763

A copy of each cited application is enclosed.

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JAN 16 2004
TC 1700
FEBRUARY 24 2003
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It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No.



FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)			ATTY DOCKET NO. 03500.015313.		APPLICATION NO. 09/837,459	
<div style="position: absolute; left: 0; top: 0; width: 100px; height: 100px; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px;"> U.S. DEPT. OF COMMERCE PATENT & TRADEMARK OFFICE AUG 19 2002 </div>			APPLICANT HIROSHI IZAWA ET AL.			
			FILING DATE APRIL 19, 2001		GROUP 2857	
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,113,732	09/05/00	YOSHIDA ET AL.	156	345	RECEIVED JUN 05 2003 TC 1700
						RECEIVED JAN 17 2003
						TECHNOLOGY CENTER R3700
						RECEIVED OCT 09 2003
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)						
RECEIVED JUN 16 2003 TECHNOLOGY CENTER R3700			RECEIVED AUG 28 2002 TC 1700			
RECEIVED JAN 15 2004 TC 1700			RECEIVED OCT 28 2003 TC 1700			
EXAMINER			DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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